



## UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Grant W. McEwan et al GROUP ART UNIT: 2813  
APPLN. NO.: 10/736,395 EXAMINER: Thanh T. Nguyen  
FILED: December 15, 2003  
TITLE: METHOD FOR PRODUCING CORROSION OF METAL SURFACES  
DURING SEMICONDUCTOR PROCESSING

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Certificate of Mailing

Date of deposit:

August 25, 2005

I hereby certify that this paper is being deposited with the United States Postal Service on the date indicated above, as first-class mail, with sufficient postage attached thereto, in an envelope addressed to the Commissioner for Patents, Alexandria, VA 22313.

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Printed Name of Person Mailing Paper

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 13, 2005, and Examiner's comments with regard thereto, please enter the following amendments in the above-entitled application, without prejudice or disclaimer.

If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 503079.